

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of Applicants: Date: November 25, 2008  
Haight et al. Group Art Unit: 3742  
Serial No.: 09/933,461 Examiner: Geoffrey S. Evans  
Filed: August 20, 2001 Docket No.: YOR919980510US2  
For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents  
P.O. Box 1450  
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**SUPPLEMENTAL RESPONSE TO OFFICE ACTION DATED 05/07/2008**

Amendments to the claims begin on 2 page of this paper.

Remarks begin on 20 page of this paper.